

# SELECTIVE WAFER ELEVATOR

## SWE150MM; SWE200MM

- 100/125MM WAFER HANDLING
- 150MM WAFER HANDLING**
- 200MM WAFER HANDLING
- VACUUM HANDLING SYSTEMS
- RETICLE HANDLING
- WAFER CARRIERS
- CARRIER HANDLES

SWE  
150

SWE  
200



### SPECIFICATIONS (MM)

<b>SWE150:</b>	L 195 x W 170 x H 180mm
<b>SWE200:</b>	L 205 x W 195 x H 180mm

### DESCRIPTION

The Selective Wafer Elevator is a manually activated tool used to elevate a wafer from a Semi-Standard carrier. The wafer is held in an elevated position until the mechanism is released.

The operator can select every fifth wafer to be elevated, starting at slot 1-5 (for example, every wafer in slot 1, 6, 11, 16, 21).

The open design and use of organic materials ensures ultra-clean handling without disturbing the laminar flow of the clean room.

The equipment is available in 150mm or 200mm versions.



### RECIF TECHNOLOGY

This tool has been designed under license from Recif Technologies using the same design principles, materials and kinematics as were used in the original equipment and wafer fabs around the world.

SUPPLIERS TO THE SEMICONDUCTOR INDUSTRY

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